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Attorney Docket No. 80585(302765)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **YAMADA Toshiro et al.**

Group Art Unit: 1765

Serial No.: 10/520,272

Examiner: AHMED, SHAMIM

Filed: January 14, 2005

P.T.O. Confirmation No.: 4526

**FOR: METHOD OF DRY ETCHING, DRY ETCHING GAS AND PROCESS FOR
PRODUCING PERFLUORO-2-PENTYNE**

MAIL STOP: AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT UNDER 37 CFR §1.111

DO NOT
Enter.
SA
9/25/07

In response to the First Office Action dated June 6, 2007, please amend the above-captioned patent application as follows, as shown in the complete listing of the claims:

Amendments to the claims begin on page 2 of this paper.

Remarks begin on page 4 of this paper.